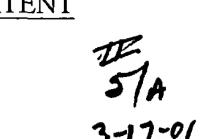
Docket No.: 1268-093A





IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Moshe FINAROV

Serial No. Not yet assigned

Filed: July 26, 2000

Group Art Unit: Not yet assigned

Examiner:

For:

AN APPARATUS FOR INTEGRATED MONITORING OF WAFERS AND FOR PROCESS CONTROL IN THE SEMICONDUCTOR MANUFACTURING AND A

METHOD FOR USE THEREOF

PRELIMINARY AMENDMENT

Assistant Commissioner For Patents Washington, D. C. 20231

Sir:

Preliminary to examination of the above-referenced application, please amend the application:

IN THE SPECIFICATION:

On page 1, after the title, please insert the following:

--The present application is a continuation-in-part of U.S. Application Serial No. 09/509,080 filed March 22, 2000, entitled AN APPARATUS FOR INTEGRATED MONITORING OF WAFERS AND FOR PROCESS CONTROL IN THE SEMICONDUCTOR MANUFACTURING AND A METHOD FOR USE THEREOF--.

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